

L Number	Hits	Search Text	DB	Time stamp
1	23790	(SiGe (silicon near5 germanium))	USPAT; US-PGPUB	2004/04/27 11:06
4	5758	((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) same (SiGe (silicon near5 germanium)))	USPAT; US-PGPUB	2004/04/27 11:01
5	3377	((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) with (SiGe (silicon near5 germanium)))	USPAT; US-PGPUB	2004/04/27 10:50
6	2515	((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) near5 (SiGe (silicon near5 germanium)))	USPAT; US-PGPUB	2004/04/27 10:49
7	5758	((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) same (SiGe (silicon near5 germanium))) ) (((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) with (SiGe (silicon near5 germanium))) ) (((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) near5 (SiGe (silicon near5 germanium))) )	USPAT; US-PGPUB	2004/04/27 10:49
9	776	(((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) same (SiGe (silicon near5 germanium))) ) (((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) with (SiGe (silicon near5 germanium))) ) (((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) near5 (SiGe (silicon near5 germanium))) ) and ((pattern\$4 etch\$3) with (SiGe (silicon near5 germanium)))	USPAT; US-PGPUB	2004/04/27 11:03
10	1510	(((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) same (SiGe (silicon near5 germanium))) ) (((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) with (SiGe (silicon near5 germanium))) ) (((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) near5 (SiGe (silicon near5 germanium))) ) and ((pattern\$4 etch\$3) same (SiGe (silicon near5 germanium)))	USPAT; US-PGPUB	2004/04/27 10:51
11	191	(((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) same (SiGe (silicon near5 germanium))) ) (((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) with (SiGe (silicon near5 germanium))) ) (((SiGe (silicon near5 germanium)) ) and ((implant\$3 dop\$4) near5 (SiGe (silicon near5 germanium))) ) and ((pattern\$4 etch\$3) near (SiGe (silicon near5 germanium)))	USPAT; US-PGPUB	2004/04/27 10:51





20	0	((SiGe (silicon near5 germanium)) ) and (smart near5 cut)	EPO; JPO; DERWENT; IBM_TDB USPAT; US-PGPUB	2004/04/27 11:05
21	1	(SiGe (silicon near5 germanium)) near100 (transfer\$4 bond\$3) near100 (etch\$3 pattern\$4) near100 (inulat\$3 dielectric)		2004/04/27 11:08
22	48	(SiGe (silicon near5 germanium)) same (transfer\$4 bond\$3) same (etch\$3 pattern\$4) same (inulat\$3 dielectric)	USPAT; US-PGPUB	2004/04/27 11:08